



Docket No.: H6808.0004/P004  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Atsushi Takane et al.

Application No.: 10/082,286

Confirmation No.: 5346

Filed: February 26, 2002

Art Unit: 2881

For: SEMICONDUCTOR INSPECTION SYSTEM

Examiner: P. A. Johnston

**AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated November 4, 2005, finally rejecting claims 1-25, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.